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Bib Data Sheet

CONFIRMATION NO. 2218

SERIAL NUMBER 09/903,600	FILING DATE 07/12/2001 RULE	CLASS 356	GROUP ART UNIT 2877	ATTORNEY DOCKET NO. S004-4331	
APPLICANTS Ryoichi Matsuoka, Chiba-shi, JAPAN; ** CONTINUING DATA ***** <i>None</i> ** FOREIGN APPLICATIONS ***** JAPAN 2000-214845 07/14/2000 <i>Yes</i> IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 08/23/2001					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>[Signature]</i> Examiner's Signature <i>cd</i> Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 3	TOTAL CLAIMS 4	INDEPENDENT CLAIMS 2
ADDRESS ADAMS & WILKS 31st Floor 50 Broadway New York ,NY 10004					
TITLE Wafer pattern observation method and device					
FILING FEE RECEIVED 840	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		